

Attorney Docket: 061063-0306592
Client Reference: OSP-15151

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

RE PATENT APPLICATION OF
HASEGAWA et al.
Appln. No. 10/696,702

Confirmation No.: Unassigned
Group Art Unit: 2823
Examiner: Estrada, Michelle

Filed: October 30, 2003

Title: SEMICONDUCTOR MANUFACTURING METHOD AND SEMICONDUCTOR
MANUFACTURING APPARATUS

* * * * *

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Attached is a PTO-1449.

The references were cited in the parent application, 10/254,601, on which the instant application relies for priority under 35 U.S.C. §120. The Examiner is respectfully requested to consider each reference and return the PTO-1449 in accordance with MPEP §609 by initialing each reference and signing and dating the PTO-1449. The undersigned certifies that the references were first cited by the Patent Office not more than three months prior to the filing of this IDS.

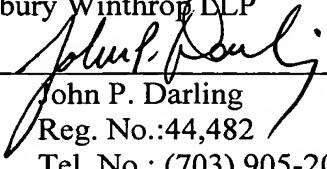
This IDS is intended to be in full compliance with the rules, but should the Examiner find any part of its required content to have been omitted, prompt notice to that effect is earnestly solicited, along with additional time under Rule 97(f), to enable Applicants to comply fully.

This IDS is being submitted prior to the first Official Action on the merits, accordingly, no fee is due.

Consideration of the enclosed references and prompt and favorable examination on the merits are respectfully requested.

Respectfully submitted,

Pillsbury Winthrop LLP

By: 

John P. Darling

Reg. No.: 44,482

Tel. No.: (703) 905-2045

Fax No.: (703) 905-2500

Date: December 9, 2003

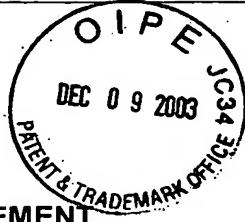
P.O. Box 10500
McLean, VA 22102
(703) 905-2000

Enclosures:

PTO-1449

Cited References

JPD/tmt



Atty. Dkt. No.	M#	Client Ref.
	0306592	OSP-15151
Applicant: HASEGAWA et al.		
Appln. No.: 10/696,702		
Filing Date: October 30, 2003		
Examiner: Estrada, M.		Group Art Unit: 2823

Date: December 9, 2003

Page **1** of **1**

U.S. PATENT DOCUMENTS

Examiner's Initials*	Document Number	Date MM/YYYY	Name (Family Name of First Inventor)	Class	Sub Class	Filing Date (if appropriate)
AR	5,241,851	09/1993	Tapp et al.	73	29.01	
BR						
CR						
DR						
ER						
FR						
GR						
HR						
IR						
JR						
KR						
LR						
MR						
NR						

FOREIGN PATENT DOCUMENTS

	Document Number	Date MM/YYYY	Country	Inventor Name	English Abstract		Translation Readily Available	
					Enclosed	No	Enclose	No
OR	JP 10-335249	12/1998	Japan	Hashim		X		
PR								
QR								
RR								
SR								
TR								
UR								
VR								
WR								
XR								

OTHER (Including in this order Author, Title, Periodical Name, Date, Pertinent Pages, etc.)

YR			
ZR			
AAR			
BBR			
CCR			
DDR			

Examiner

Date Considered:

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.